



Docket No.: 0756-7285

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT application of )  
Koichiro TANAKA )  
Serial No. 10/827,431 ) Group Art Unit: 2872  
Filed: April 20, 2004 ) Examiner: James Phan  
For: BEAM IRRADIATION APPARATUS, BEAM )  
IRRADIATION METHOD, AND METHOD FOR )  
MANUFACTURING THIN FILM TRANSISTOR )

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria VA 22313-1450, on October 30, 2006

**REQUEST FOR STATUS**

Honorable Commissioner of Patents


P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action on the Response to Notice of Non-Compliance and Preliminary Amendment which were filed May 4, 2006 in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

  
Eric J. Robinson  
Reg. No. 38,285

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